

APR 14 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Brian T. Rosenberger, et al.

Serial No.

10/010,506

Filing Date:

November 13, 2001

Group Art Unit:

2872

Examiner:

Unknown

Title:

SYSTEM AND METHOD FOR THE HOLOGRAPHIC DEPOSITION
OF MATERIAL

Commissioner of Patents

Washington, D.C. 20231

Certification Under 37 C.F.R. 1.8

Date of Mailing: April 8, 2003

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage to be transmitted via first class mail under 37 CFR § 1.8 on the date indicated above and addressed to: Commissioner of Patents, Washington, D.C. 20231.

Rebecca J. Morrison
Rebecca J. Morrison

Dear Sir:

PRELIMINARY AMENDMENT

Please amend the Application as follows:

IN THE SPECIFICATION

Please add the following new paragraph as the first paragraph on page 1

-- CROSS-REFERENCE TO RELATED APPLICATION

This application claims the benefit of priority to U.S. Provisional Patent Application No. 60/249,678 entitled "System and Method for Holographic Deposition of Material", filed on November 17, 2000, and is incorporated herein by reference in its entirety. --

Please delete the first paragraph after the section title, BACKGROUND OF THE INVENTION on page 1, as follows:

[This application claims priority of U.S. Provisional Application, Serial No. 60/249,678, filed November 17, 2000 entitled: "System and Method for Holographic Deposition of Material", and is incorporated herein by reference in its entirety.]

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